

Form PTO 1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	ATTY. DOCKET NUMBER NITT.0186	SERIAL NUMBER To be Assigned
	APPLICANT KIKAWA et al.	
	FILING DATE Concurrently Herewith	GROUP

U.S. Patent Documents

Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>JR</i>	5,063,173	11/5/91	Gasser et al.			6/15/90

Foreign Patent Documents

Examiner Initial	DOCUMENT NUMBER	FILING DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
<i>JR</i>	2003-86884	9/10/2001	Japan			Abstract	X
<i>JR</i>	2002-223026	1/24/2001	Japan			Abstract	X

Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)

<i>JR</i>	Tonao Yuasa et al., "Facet Protection of (AlGa) As Lasers Using SiO ₂ Sputter Deposition", Appl. Phys. Lett, Vol. 34, No. 10, (May 15, 1979), pp. 685-687

EXAMINER <i>J. MONDT JR</i>	DATE CONSIDERED <i>02/21/05.</i>
--------------------------------	-------------------------------------

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant